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CONFIRMATION NO. 4454

|  |                                   |   |                        |                                     |                         |
|--|-----------------------------------|---|------------------------|-------------------------------------|-------------------------|
| SERIAL NUMBER<br>10/648,172  | FILING DATE<br>08/25/2003<br>RULE | CLASS<br>438  | GROUP ART UNIT<br>1765 | ATTORNEY<br>DOCKET NO.<br>51876P377 |                         |
| <b>APPLICANTS</b><br><p>Sung-Kwon Lee, Ichon-shi, KOREA, REPUBLIC OF;</p> <p>** CONTINUING DATA ***** <i>None</i> <i>K-cc</i></p> <p>** FOREIGN APPLICATIONS ***** <i>K-cc</i><br/>   REPUBLIC OF KOREA 2002-85131 12/27/2002<br/>   REPUBLIC OF KOREA 2002-86489 12/30/2002</p> <p>IF REQUIRED, FOREIGN FILING LICENSE GRANTED<br/>   ** 11/15/2003</p> |                                   |   |                        |                                     |                         |
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no<br>35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after<br>Allowance <i>K-cc</i><br>Verified and Acknowledged<br>Examiner's Signature <i>K-cc</i> Initials                |                                   | STATE OR COUNTRY<br>KOREA,<br>REPUBLIC OF   | SHEETS<br>DRAWING 12   | TOTAL<br>CLAIMS 19                  | INDEPENDENT<br>CLAIMS 3 |
| <b>ADDRESS</b><br>08791<br>BLAKELY SOKOLOFF TAYLOR & ZAFMAN<br>12400 WILSHIRE BOULEVARD<br>SEVENTH FLOOR<br>LOS ANGELES , CA<br>90025-1030   |                                   |   |                        |                                     |                         |
| <b>TITLE</b><br>Method for fabricating semiconductor device using ArF photolithography capable of protecting tapered profile of hard mask  |                                   |   |                        |                                     |                         |
| <b>FILING FEE</b><br>FEES: Authority has been given in Paper   |                                   | <input type="checkbox"/> All Fees<br><input type="checkbox"/> 1.16 Fees ( Filing )<br><input type="checkbox"/> 1.17 Fees ( Processing Ext. of |                        |                                     |                         |